



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/705,814
Filing Date: November 10, 2003
Applicant: Shinichi Nakamura
Group Art Unit: 2861
Examiner: Lamson D. Nguyen
Title: Method of Determining An Abnormality Of Nozzles In
Imaging Apparatus; Imaging Apparatus; Electrooptic
Device; Method of Manufacturing Electrooptic Device;
and Electronic Equipment
Attorney Docket: 9319H-000586

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT

Sir:

In response to the Office Action mailed July 12, 2005, please amend the application as follows and consider the remarks set forth below.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 5 of this paper.